

Search Notes

Application/Control No.

10/510,918

Examiner

Steven D. Maki

Applicant(s)/Patent under
Reexamination

NAKAMURA, ICHIZOU

Art Unit

1733

SEARCHED

| Class | Subclass | Date | Examiner |
|---------|----------|-----------|------------|
| 152 | 209.11 | | |
| | 209.12 | | |
| | 209.18 | | |
| | 209.19 | | |
| | 902 | | |
| updated | above | 4/15/2007 | <i>SDM</i> |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|------|----------|
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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|------|-----------|------------|
| none | 4/15/2007 | <i>SDM</i> |
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